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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Alvin P. Short

Examiner: Anh D. Mai

Serial No.: 09/852,899

Group Art Unit: 2812

Filed: May 10, 2001

Docket: 01 P 08366 US (2055-25)

For: Increase In Deep Trench Capacitance By A Central Ground Electrode

Assistant Commissioner for Patents
Washington D.C. 20231

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RESPONSE TO RESTRICTION REQUIREMENT

In response to the Office Action dated March 19, 2002, Applicant provisionally elects the claims of Group I (claims 1-6), with traverse. While the device of Group I and the method of Group II may be distinct for the reasons set forth by the Examiner, Applicant believes that simultaneous examination will not present an undue burden. For example, the claims of Group I are drawn to a semiconductor device having a trench and the claims of Group II are drawn to a method of forming a trench capacitor. The two Groups of claims include subject matters that are classified commonly. Under such circumstances, the Examiner is encouraged to maintain all claims in the same application. See, MPEP §803.

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Commissioner of Patents and Trademarks Office, Washington, D.C. 20231 on April 19, 2002.

Dated: 4/19/02

Frank Chau

Early and favorable consideration of this application is earnestly solicited.

Respectfully submitted,



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